

11/27/2009

ASMEX.433A

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Matthew G. Goodman, et al.
App. No : 10/775,522
Filed : February 10, 2004
For : TWO-STAGE LOAD FOR
PROCESSING BOTH SIDES OF A
WAFER
Examiner : Sylvia MacArthur
Art Unit : 1792

RESPONSE TO OFFICE ACTION

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action dated September 15, 2009, Applicants have timely filed this Response. Applicants respectfully request the Examiner to grant allowance of this application in view of the following remarks:

Listing of the Claims begins on page 2 of this paper.

Summary of Interview begins on page 4 of this paper.

Remarks begin on page 5 of this paper.